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PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Takeshi KIJIMA et al.

Group Art Unit: 1775

Application No.: 10/690,021

Filed: October 22, 2003

Docket No.: 117581

For: FERROELECTRIC FILM, FERROELECTRIC CAPACITOR, FERROELECTRIC
MEMORY, PIEZOELECTRIC ELEMENT, SEMICONDUCTOR ELEMENT,
METHOD OF MANUFACTURING FERROELECTRIC FILM, AND METHOD OF
MANUFACTURING FERROELECTRIC CAPACITOR

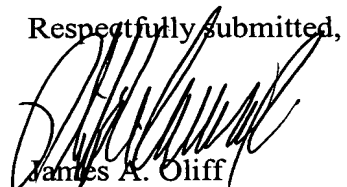
STATUS INQUIRY LETTER

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Please telephone our firm's Patent Application Filing Department at 703-836-6400 with the status of the above-identified patent application, including an indication as to when the next communication can be expected.

Respectfully submitted,



James A. Oliff
Registration No. 27,075

Philip A. Caramanica, Jr.
Registration No. 51,528

JAO:PAC/mps

Date: April 15, 2005
OLIFF & BERRIDGE, PLC
P.O. Box 19928
Alexandria, Virginia 22320
Telephone: (703) 836-6400